AMENDMENTS TO THE CLAIMS:

This listing of claims will replace all prior versions, and listings, of claims in the application:

Claims 1-61 (Canceled).

62. (New) A nitride semiconductor light emitting device comprising; a substrate,

a first nitride semiconductor layer having an impurity concentration within 1 x 10¹⁷/cm³, said first nitride semiconductor layer being a single layer,

a second nitride semiconductor layer having an n-type electrode, said second nitride semiconductor layer being a single layer,

a third nitride semiconductor layer having an impurity concentration within 1 X 10¹⁷/cm³, said third nitride semiconductor layer being a super lattice layer of InGaN layers and GaN layers.

- 63. (New) The nitride semiconductor light emitting device according to claim 62; wherein said second nitride semiconductor layer is made of GaN or AlGaN and said second nitride semiconductor layer includes Si as an n-type impurity.
- 64. (New) The nitride semiconductor light emitting device according to claim 62; wherein said first nitride semiconductor layer is made of GaN or AlGaN.

- 65. (New) The nitride semiconductor light emitting device according to claim 62; wherein said second nitride semiconductor layer has an carrier concentration more than 3 X 10¹⁸/cm³.
- 66. (New) The nitride semiconductor light emitting device according to claim 62; wherein said second nitride semiconductor layer has a resistivity less than 8 x 10⁻³ ohm * cm.
- 67. (New) The nitride semiconductor light emitting device according to claim 62; further comprising a buffer layer between said substrate and said first nitride semiconductor layer.
- 68. (New) The nitride semiconductor light emitting device according to claim 62; wherein said first nitride semiconductor layer has a thickness within a range of from 0.I to 20 μm.
- 69. (New) The nitride semiconductor light emitting device according to claim 62; wherein said second nitride semiconductor layer has a thickness within a range of from 0.1 to 20 μm,
 - 70. (New) A nitride semiconductor light emitting device comprising: a substrate,
- a first nitride semiconductor layer having an impurity concentration within 1 X 10¹⁷/cm³, said first nitride semiconductor layer being a single layer,

a second nitride semiconductor layer having an n-type electrode, said second nitride semiconductor layer being a single layer,

a third nitride semiconductor layer having an impurity concentration within 1 X 10¹⁷/cm³, said third nitride semiconductor layer being a super lattice layer of GaN layers.

- 71. (New) The nitride semiconductor light emitting device according to claim 70; wherein said second nitride semiconductor layer is made of GaN or AlGaN and said second nitride semiconductor layer includes Si as an n-type impurity.
- 72. (New) The nitride semiconductor light emitting device according to claim 70; wherein said first nitride semiconductor layer is made of GaN or AlGaN
- 73. (New) The nitride semiconductor light emitting device according to claim 70; wherein said second nitride semiconductor layer has an carrier concentration more than 3 X 10¹⁸/cm³.
- 74. (New) The nitride semiconductor light emitting device according to claim 70; wherein said second nitride semiconductor layer has a resistivity less than 8 X 10⁻³ ohm · cm.
 - 75. (New) The nitride semiconductor light emitting device according to claim 70;

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further comprising a buffer layer between said substrate and said first nitride semiconductor layer.

- 76. (New) The nitride semiconductor light emitting device according to claim 70; wherein said first nitride semiconductor layer has a thickness within a range of from 0.1 to 20 μ m,
- 77. (New) The nitride semiconductor light emitting device according to claim 70; wherein said second nitride semiconductor layer has a thickness within a range of from 0.1 to 20 μ m.
- 78. (New) The nitride semiconductor light emitting device according to claim 70; wherein said third nitride semiconductor layer being a super lattice layer of undoped GaN layers and Si doped GaN layers.

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AMENDMENTS TO THE DRAWINGS

The attached sheet of drawings includes changes to Figs. 1 and 2. This sheet, which includes Figs. 1 and 2, replaces the original sheet including Figs. 1 and 2.

Attachment: Replacement Sheet(s)